

GEM activities of Korea

- KCMS GEM projects and Future

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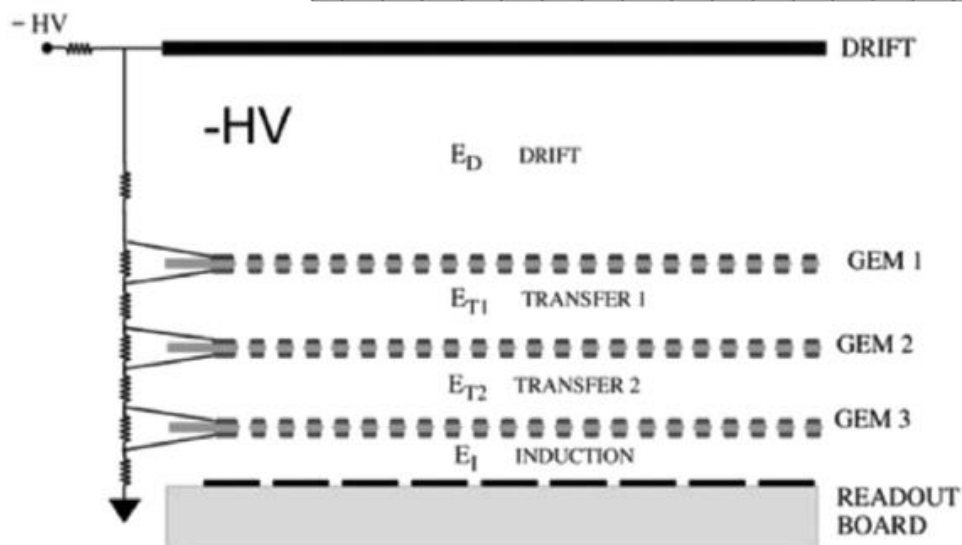
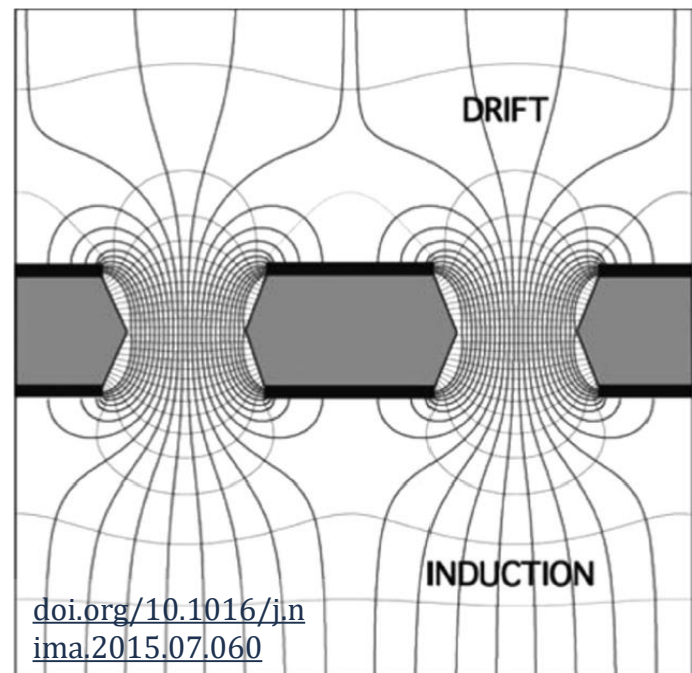
KSHEP @ PNU

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1. Introduction to GEM

- Gas Electron Multiplier
 - Detour spark generation via the **step-by-step amplification**
 - Good multi-track resolution, better than 1 mm
 - Reasonably good time resolution < 10 ns
 - Extremely high rate capability $\sim O(1 \times 10^4 \text{ Hz/mm}^2)$
 - Extremely robust to classical aging
 - Suppression of positive ion backflow
 - High material budget
- ⇒ Optimum detector for muon tracker of Lumi. frontier



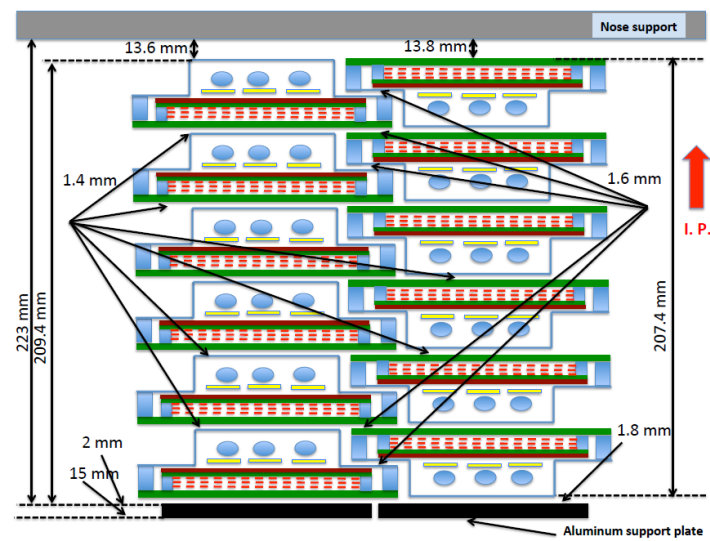
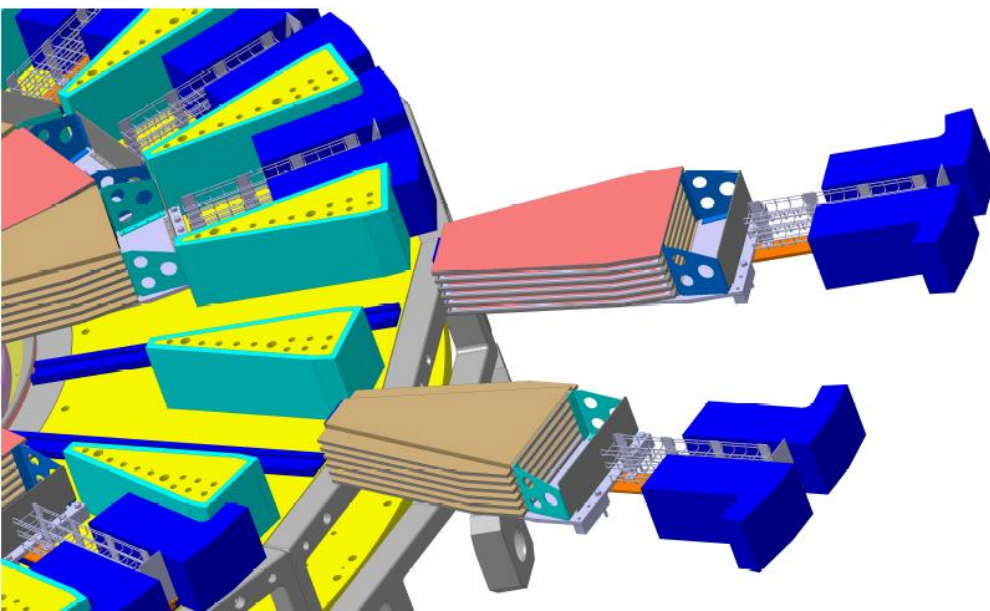
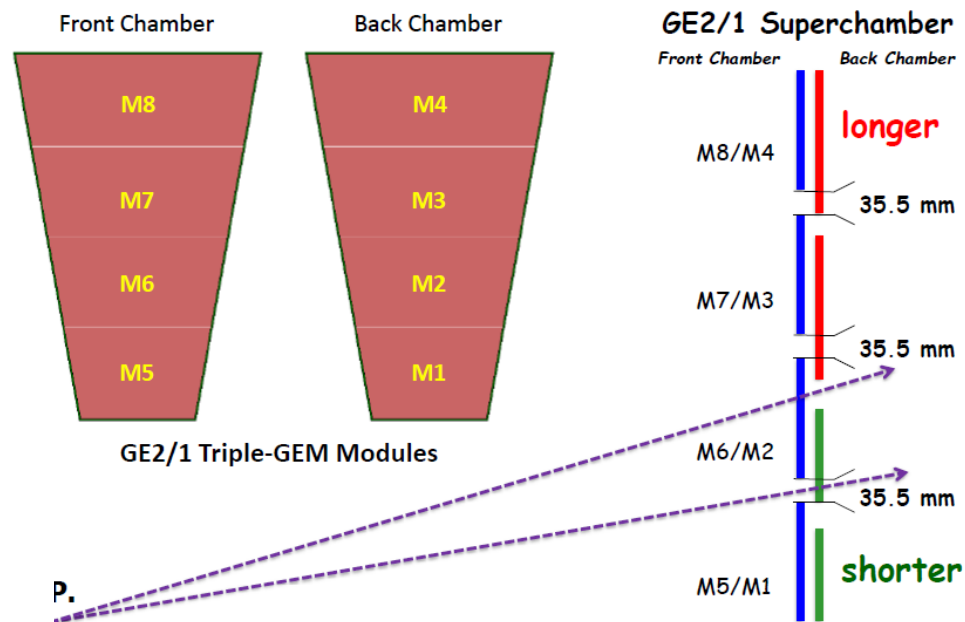
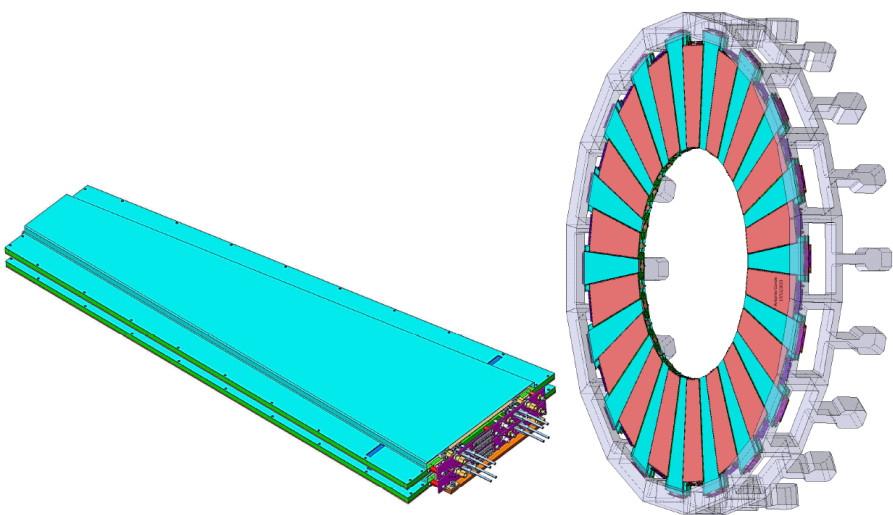
2. KCMS GEM projects – Overview

- CMS GEM upgrade for HL-LHC
 - **GE1/1, GE2/1, and ME0 upgrades**
 - To increase trigger rejection factor by increasing online muon P_T resolution
 - Triggering displaced muon
 - Increase acceptance

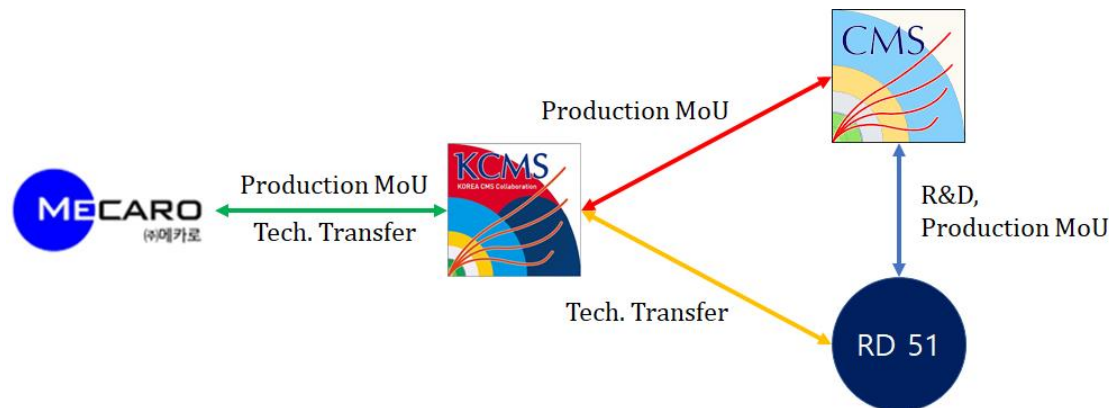
- Why GEM?
 - Thin
 - High rate capability
 - Robust to classical aging



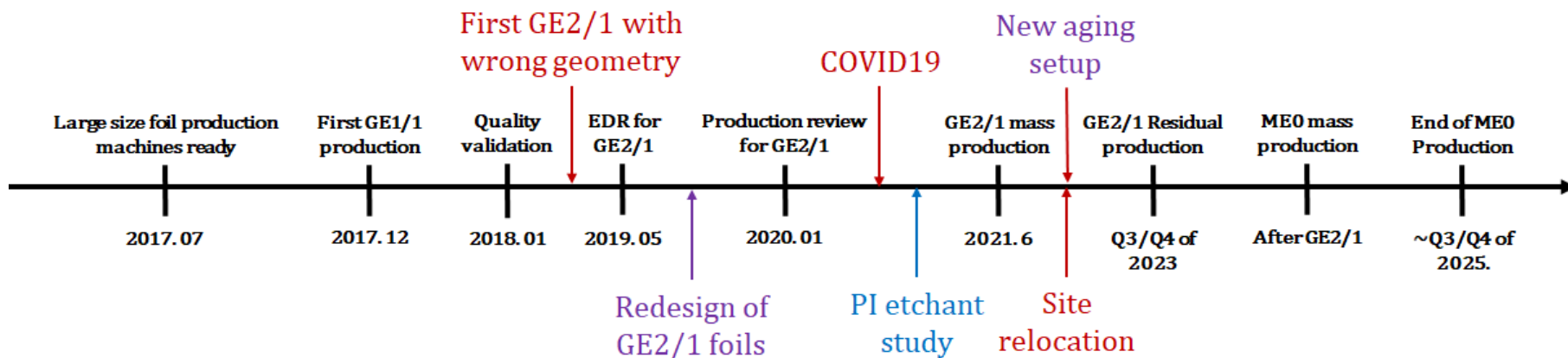
2. KCMS GEM projects – Overview



2. KCMS GEM projects – Overview



- **KCMS is supplying the large-sized GEM foil for the CMS upgrades**
 - **World only two vendors** of the large-sized GEM foils
 - GE1/1: Chance to validate foil quality produced by KCMS
 - GE2/1: KCMS shall provide **half of necessary foils**
 - ME0: KCMS shall provide **all ME0 foils**

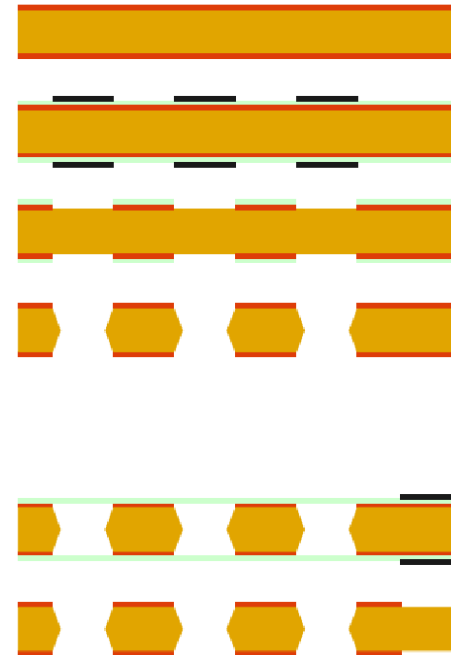


2. KCMS GEM projects – Production Processes

- Double-mask technique for simpler processes and faster production
 - Alignment become very crucial
 - Residual misalignment $< 5\mu m$
- Wet etching
 - Cu: $FeCl_3$
 - Polyimide: KOH + mono ethanolamine

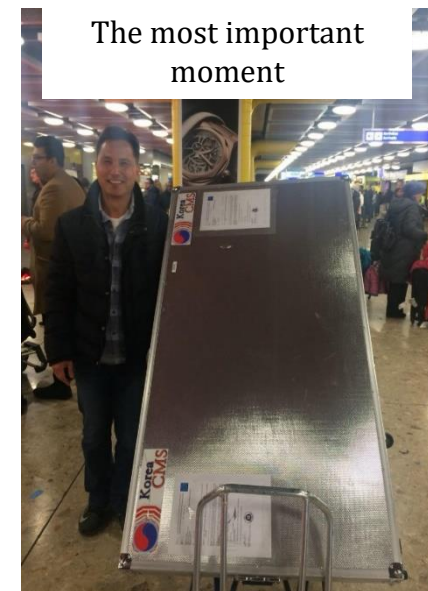
LC of MEA to mice for 2h $> 2430\text{ mg}/\text{m}^3$

Cf LC_{50} of EDA to mice = $300\text{ mg}/\text{m}^3$



3. R&D History – Validation with GE1/1

- Foil quality validation with GE1/1
 - Assemble four GE1/1 detectors with foils produced by KCMS
- **Properties of the detectors were consistent with Ref. detectors**
 - Gain, gain uniformity, rate capability, discharge prob. & robustness to discharges, aging properties
- Issue: several foils became short when HV applied after delivery
 - Foil cleaning processes, QC and packaging processes
 - **QC @ production site**
- In-cash contribution to GE1/1 project
 - Due to lack of aging measurement



The most important moment

2017, Dec, 2nd
@ Geneva airport



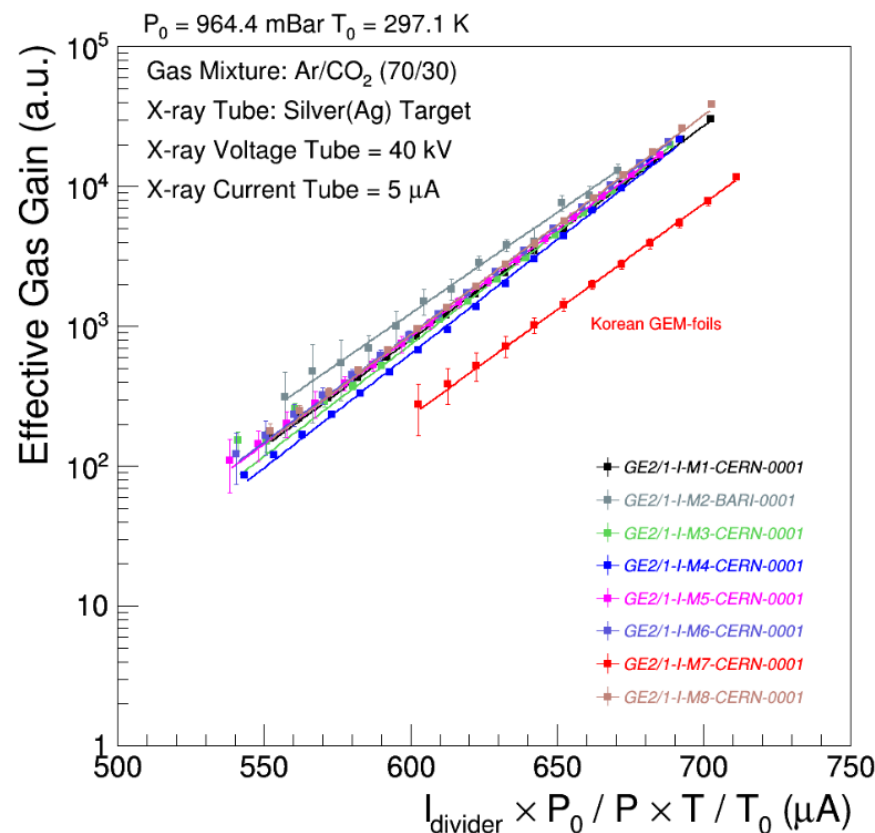
3. R&D History – First GE2/1 Production

- First GE2/1 M7 was delivered on Oct. 2018
 - Lower gain was observed
 - ∴ PI hole diameters were smaller than design

⇒ QC protocol @ production site was reviewed

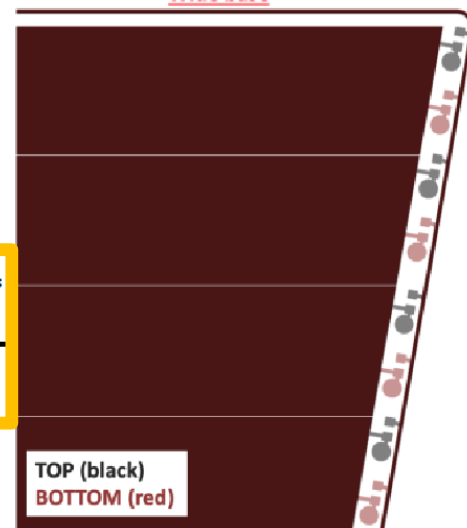
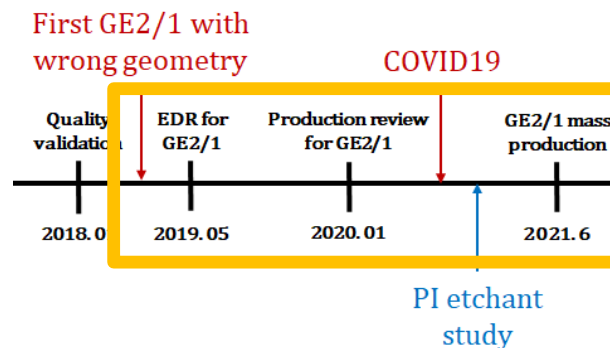
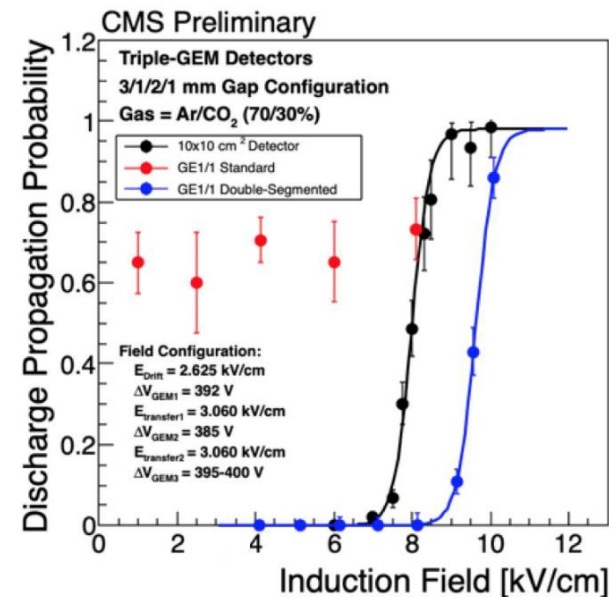
- Electrical assessment couldn't reject it
- **Optical assessment has been included**

- Fixed during PI etchant review
 - PI etching processes was updated



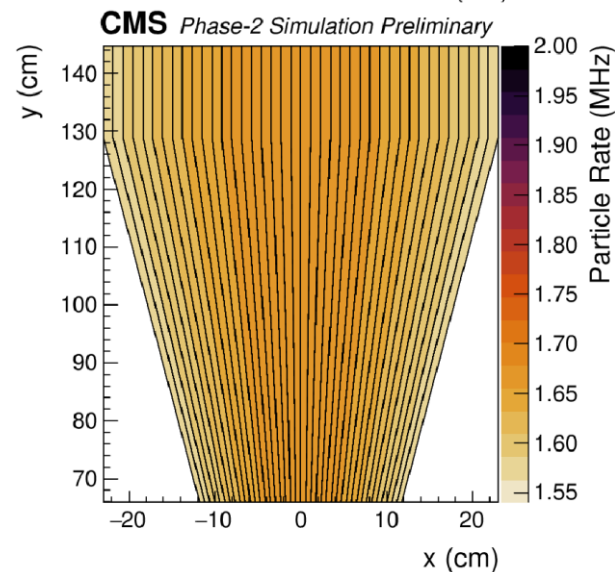
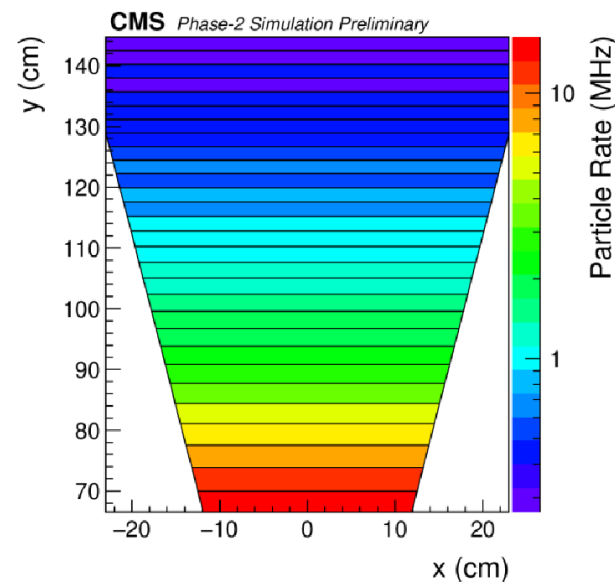
3. R&D History – Redesign of GE2/1 HV Segmentation

- Unexpected large spark rate was observed by GE1/1 slice test
 - ∴ Spark propagation between foils
- Key parameter: capacitance of gap
 - To reduce the capacitance, double-segmented foils
- Smaller capacitance of induction gap caused X-talks
 - ⇒ Double-segmented foils for GEM1&2
 - Single-segmented foils for GEM3
- Negative impact to producer
 - Production rate dropped due to doubled soldering
 - First mask became useless
 - Mass production delayed



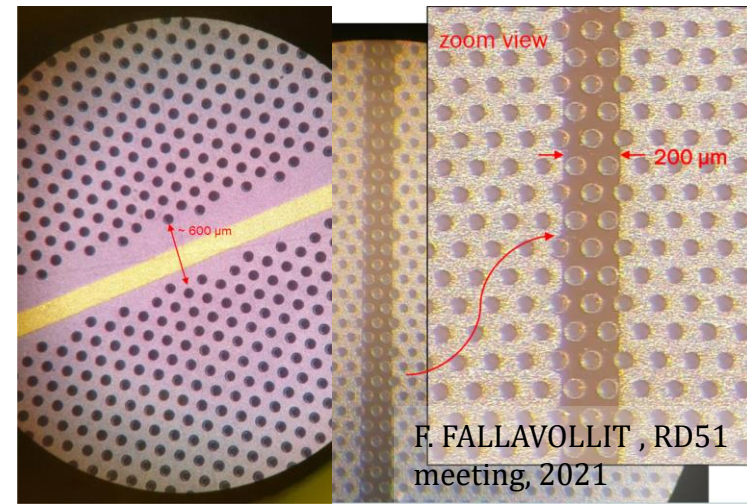
3. R&D History – New Estimation of ME0 Background

- New simulation revealed background rate at ME0 will be much higher than TDR estimation
 - Redesign of HGCal & Improper assumption of TDR simulation
- ⇒ Aging goal increased, Radial-segmentation, Shielding
- HV segmentation
 - To reduce capacitance
 - Even sectors are short, the others are operational
- Protection resistor
 - To protect foils from shorting by spark
 - Control power consumption when sectors become short (V/R^2)
 - Induce voltage drop (IR)



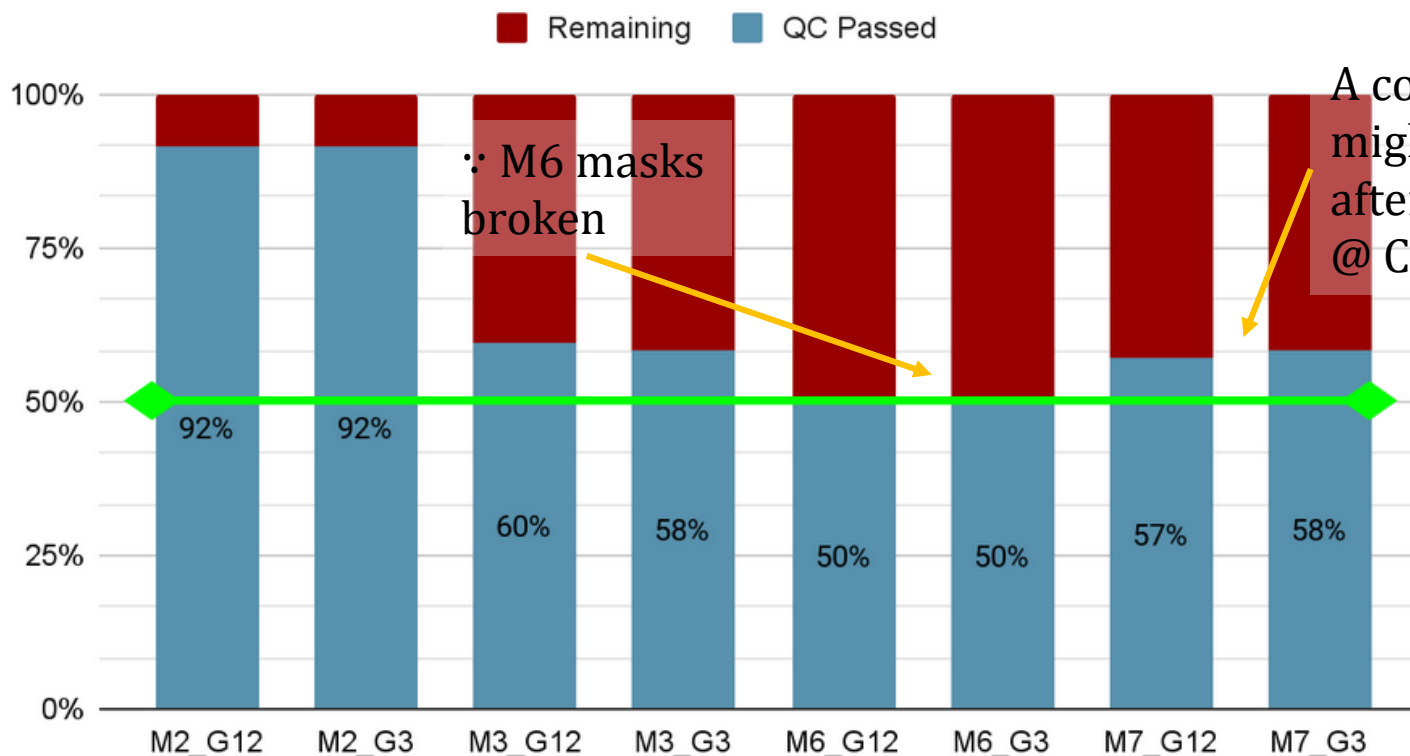
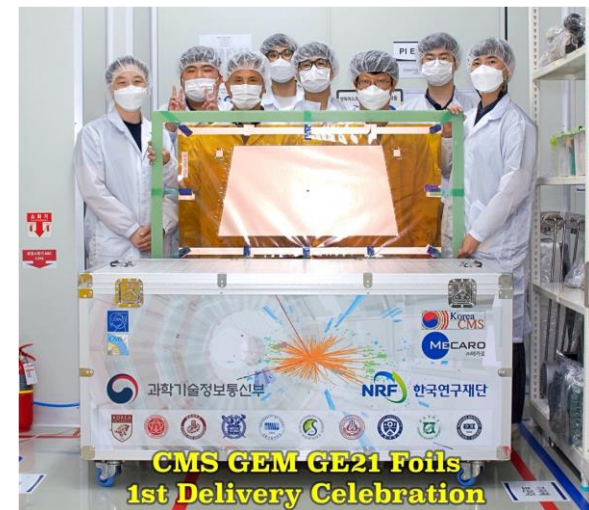
3. R&D History – Ongoing R&D

- Aging study @ UoS (Led H. Lee)
 - Expected accumulated charge: $283 \text{ mC/cm}^2 \rightarrow 7.93 \text{ C/cm}^2$
 - Aim to accumulate unprecedented amount of charge
 - Special chamber with smaller protection resistors
 - 40 W X-ray gun
 - Measure anode current variation while detector exposed to x-ray
 - Accumulation rate $\sim 52 \text{ mC/cm}^2 \text{ day}$
 - Already 1.01 C/cm^2 accumulated
- Production feasibility
 - Random & radial segmentation with double-mask technique
 - Production may be harder
 - Rui: “Production of random sectorized foils with double-mask technique has high delamination risk”



4. Mass Production so far

- Since Jun. 2021, 284 foils have passed QC
 - Led by Dr. D. Kim
- The quantity to assemble “Disk-1” is barely satisfied



A couple of foils might pass QC after treatment @ CERN

∴ M6 masks broken

5. Site Relocation & Production Plan

- KCMS & Mecaro consortium has ended
 - Looking for alternative production site
- Delays due to production shutdowns are choking us, but **as long as a new site become available, we'll have advantage**
 - After the giving GEM up became known internally, technicians didn't work hard
- IBS is best option
 - Equipment transportation has already been completed
 - Installation of cleaning room should started ASAP
- **The wet processes will be done at external factory located at Ansan (안산)**
 - Getting chemical handling permit will take long time
 - Ultimately, we hope all processes can be carried out within single organization
- Internal goal to resume foil production
 - **March, 2023 (Optimistic scenario)**

5. Site Relocation & Production Plan

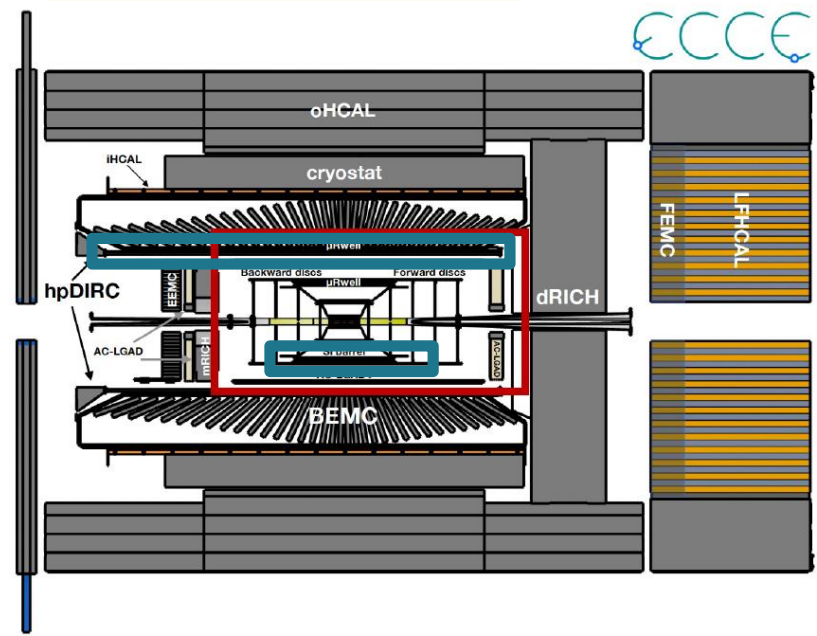
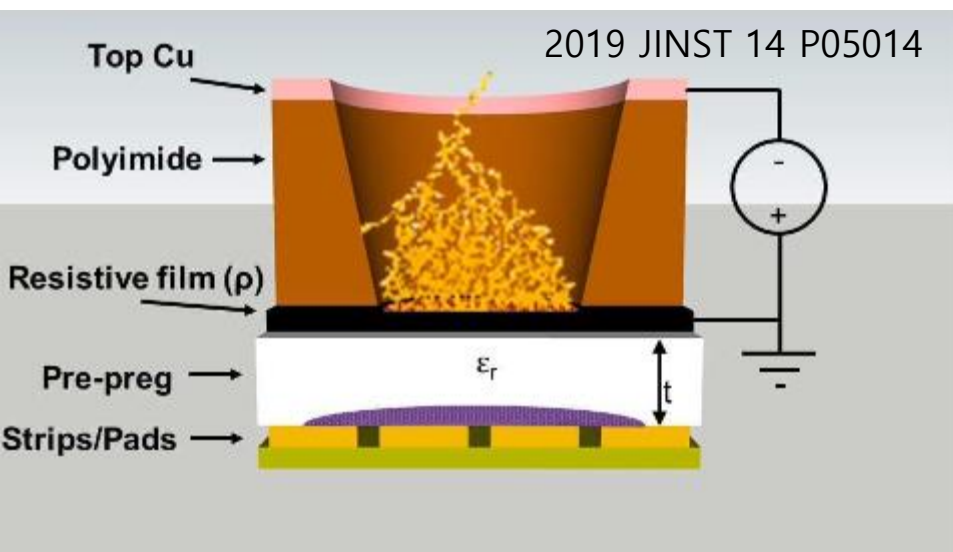
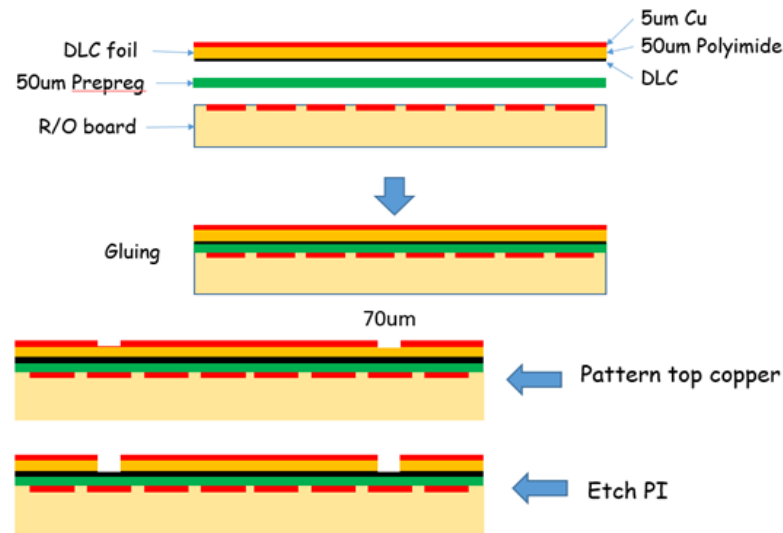
- Disk-1 should be prepared before Aug. 2023
 - **Order a couple of M6 (~8) and M7 (< 8) foils to CERN** ∴ the assembly need spare foils
- Residual GE2/1 production
 - 114 foils×4 type – 284 foils - order for spare ~ **164 foils**
 - Production rate @ Mecaro: 30-32 foils/month
 - Hard to expect the rate @ IBS
 - ⇓ Additional transportation
 - ⇑ KCMS controls all things
- Disk-2 should be prepared until Jun. 2024
 - Expected deadline: ~Q3 or early Q4 of 2023
 - ⇒ If things go well, **KCMS can finish GE2/1 production**
- **Contingency plan:** Order foils to CERN
 - We need to warn Rui by 1st Dec.

5. Site Relocation & Production Plan

- ME0 production
 - 666 foils
 - Disk-1 (Disk-2) should be ready before Aug. 25 (June. 26)
 - Expected deadline: Q3 of 2025
 - ⇒ If we start ME0 production after GE2/1 production done, production is feasible

6. Potential μ RWELL contribution to Detector 1 @ EIC

- Two μ RWELL barrels are planned for Detector 1, EIC
 - We can contribute μ RWELL
- Operating principles of μ RWELL
 - Multiplication principle: GEM like
 - Spark mitigation principle: RPC like
- GEM and μ RWELL share similar production processes
 - Only one missing technique is DLC sputtering



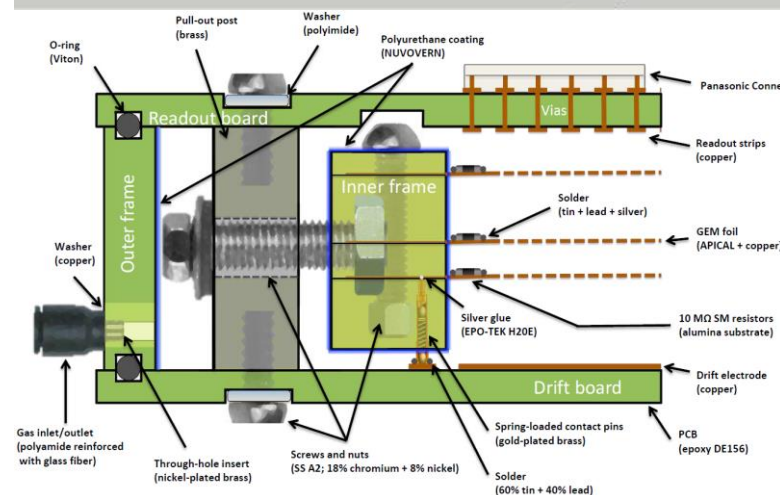
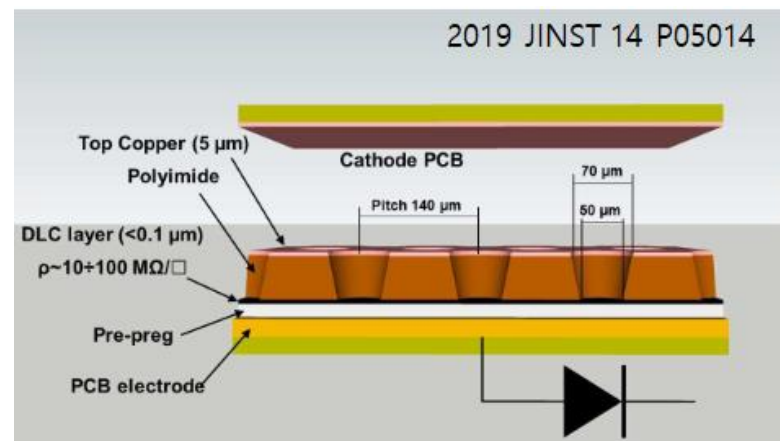
6. Potential μ RWELL contribution to Detector 1 @ EIC

- Advantages

- Leading role in EIC physics
- Maintain the initiative within MPGD production
- μ RWELL is charming

- Advantages of μ RWELL

- Only one foil to achieve high enough gain
 - Easy handling
 - Simpler assembly
 - Mass production friendly
- ⇒ Cheap
- Reasonably good performances
 - Low material budget

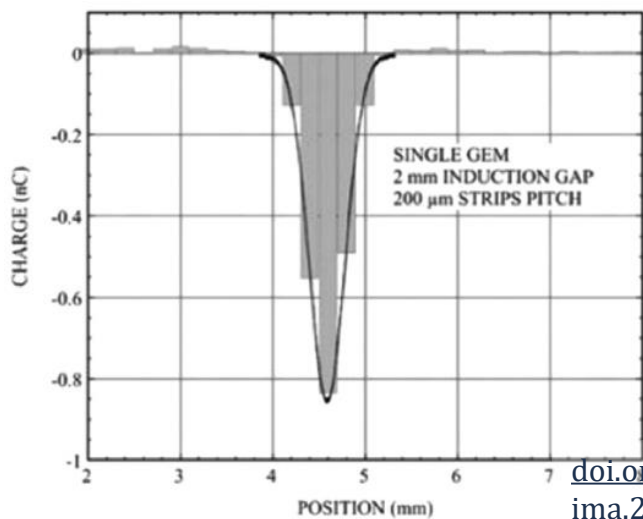


Summary

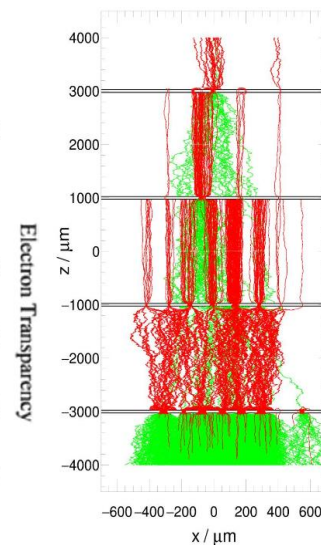
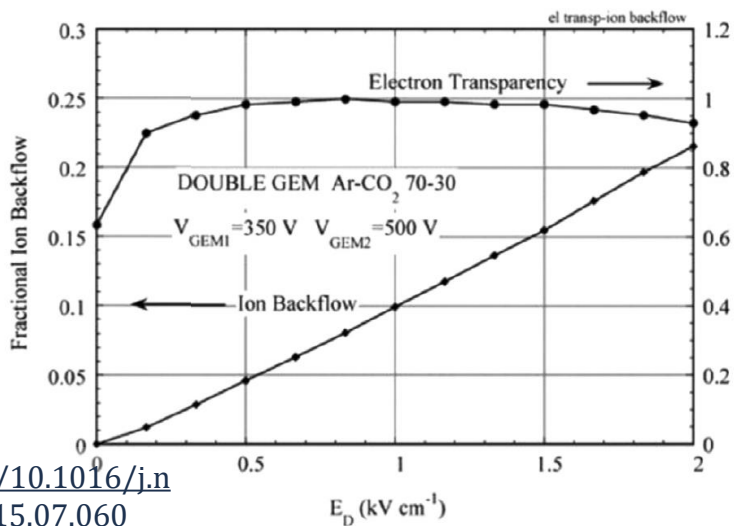
- KCMS is supplying large-sized GEM foil for CMS GEM upgrades
 - We've participated several R&D for foil production and detector R&D
- Mass production was smooth until KCMS & Mecaro consortium ended
 - So far, 284 foils have passed QC
 - ~16 foils should be ordered to CERN
- Dry processes will be done at IBS and wet processes will be done at external factory
 - Installation of clean room will start in soon
 - Contract process in ongoing with the external factory
- If things go well, KCMS can produce residual GE2/1 foils
- We can contribute μ RWELL to EIC with our own original technology!
 - Feasible

Back Up

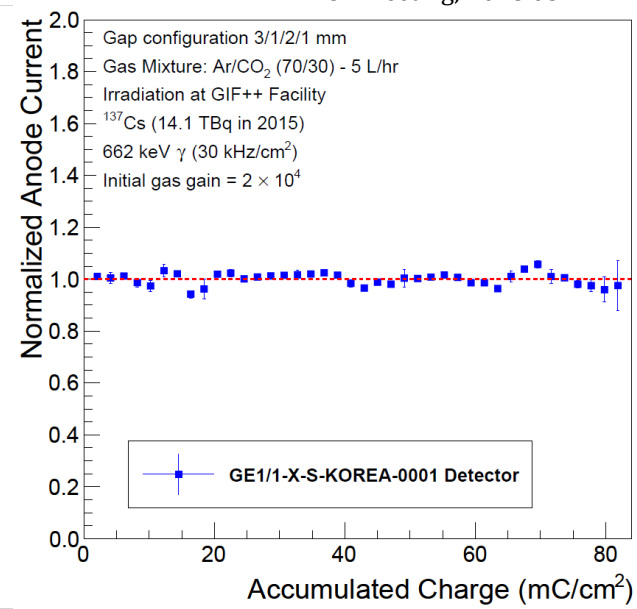
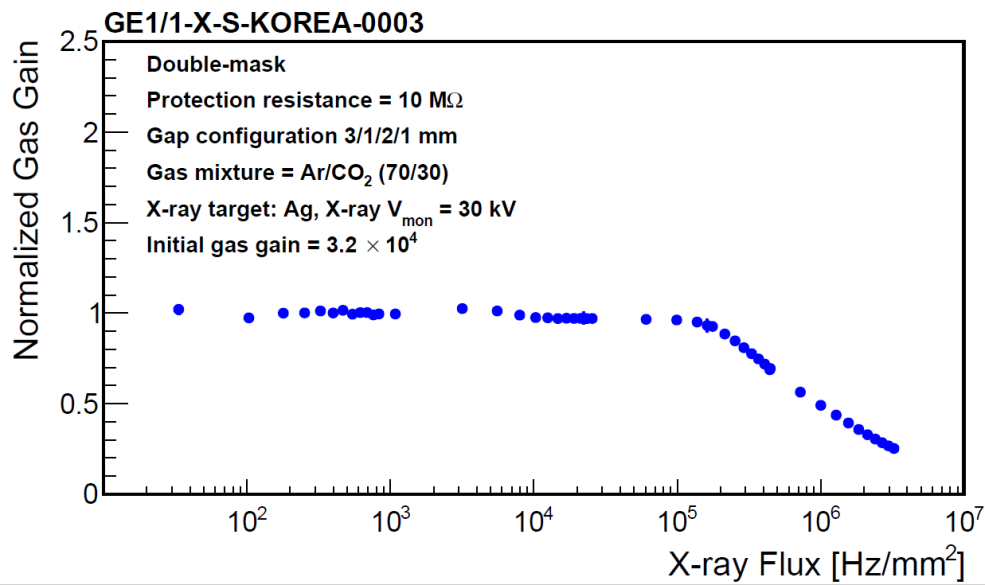
Introduction to GEM



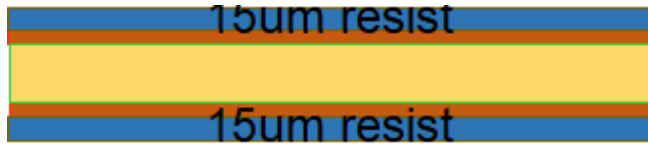
doi.org/10.1016/j.nima.2015.07.060



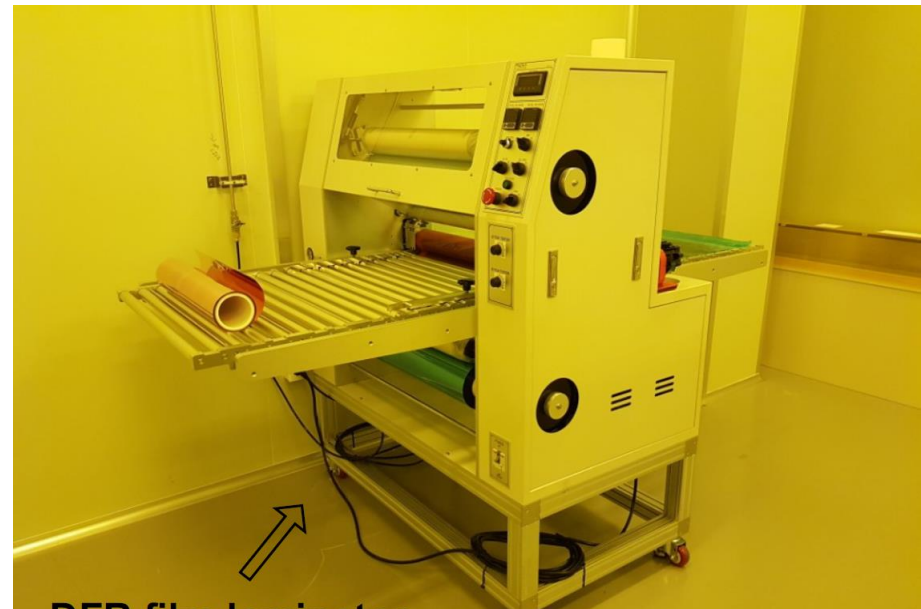
J. Ottnad,
RD51 meeting, 2018.05.12



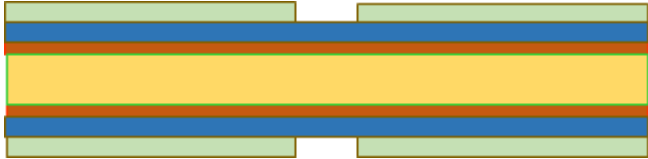
KCMS GEM project – Production Process



- Laminate DFR



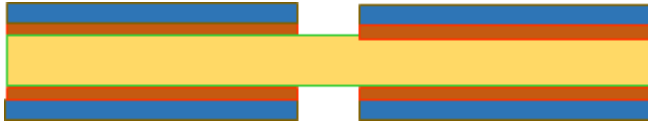
KCMS GEM project – Production Process



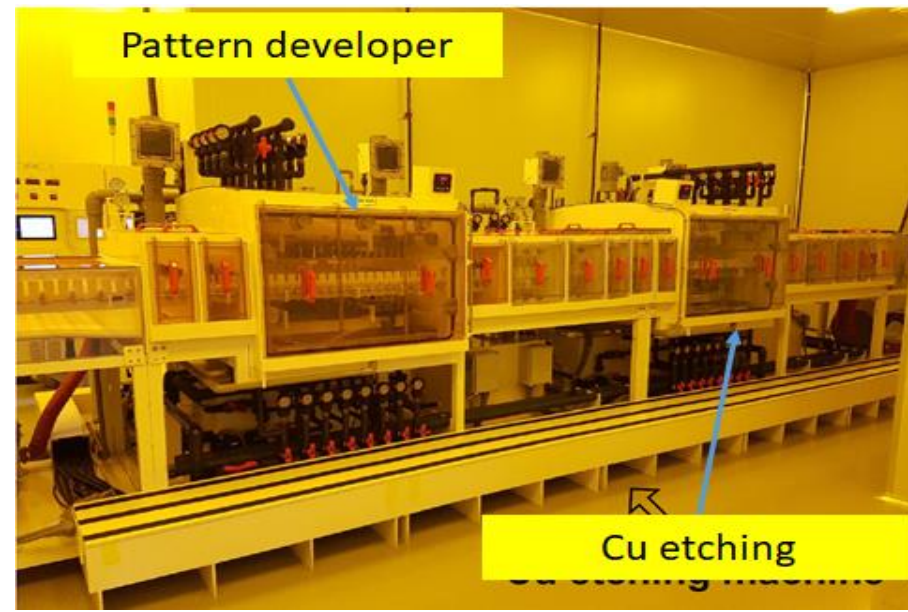
- UV exposure and pattern implantation
 - **Double-mask technique** for simpler production processes & faster production
 - Alignment of masks become crucial



KCMS GEM project – Production Process



- Developing pattern and 1st Cu etching
 - Developer: Na_2CO_3
 - Cu etching: $FeCl_3$



KCMS GEM project – Production Process



- DFR stripping
 - $NaOH$
 - Careful observation is needed to tweak dipping duration
 - ∴ $NaOH$ etches Cu



KCMS GEM project – Production Process



- Seed etching
- $KMnO_4$



KCMS GEM project – Production Process



- PI etching

- Mixture of MEA and *KOH*

- **Geometry is tunable**

- We are using MEA instead of EDA for safety

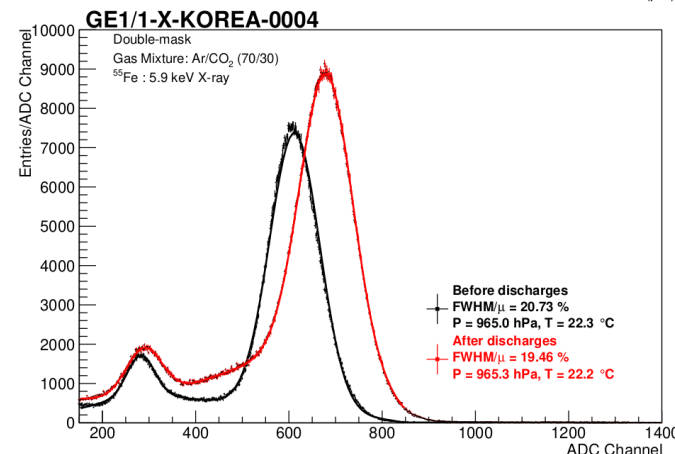
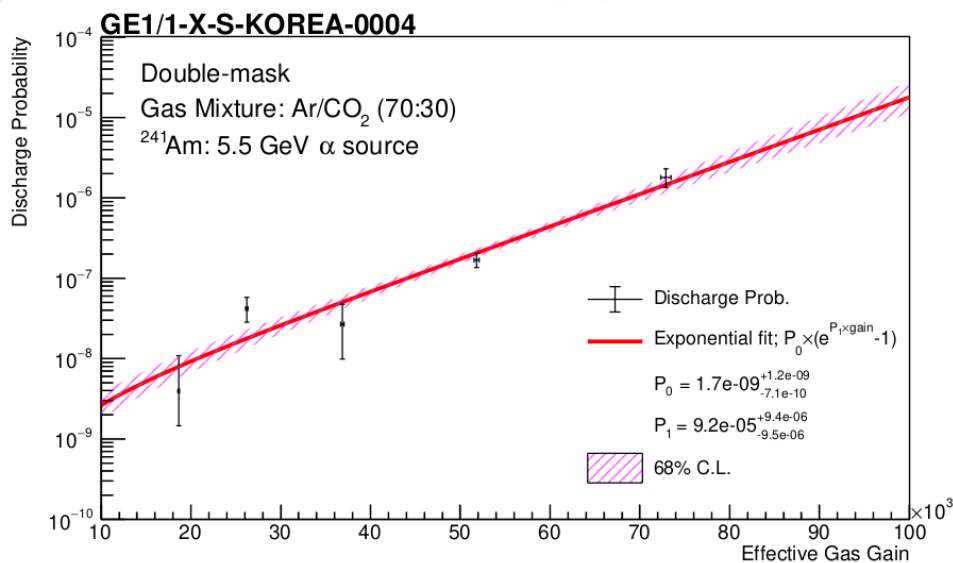
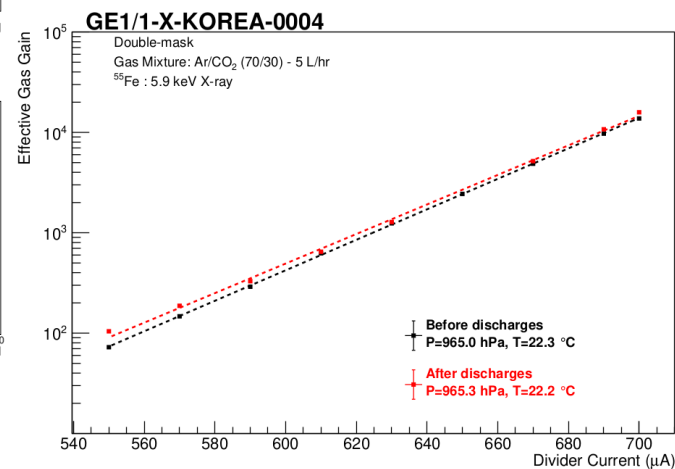
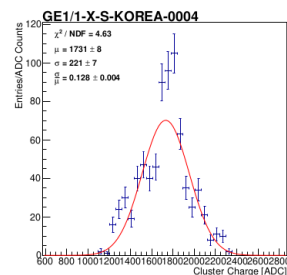
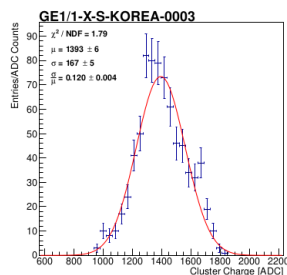
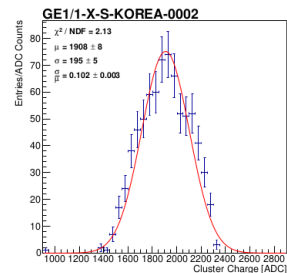
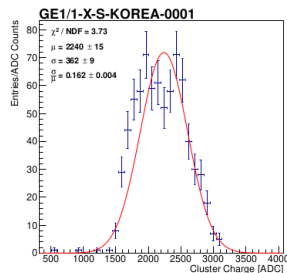
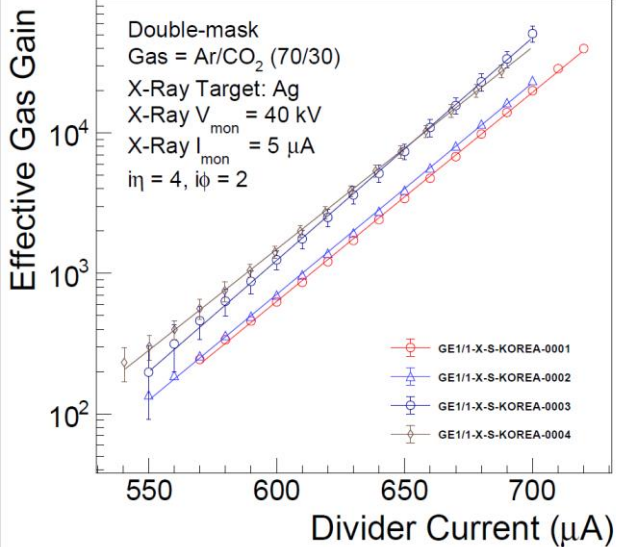
LC of MEA to mice for 2h > 2430 mg/m³ Cf *LC*₅₀ of EDA to mice = 300 mg/m³

- Need to be tuned every use



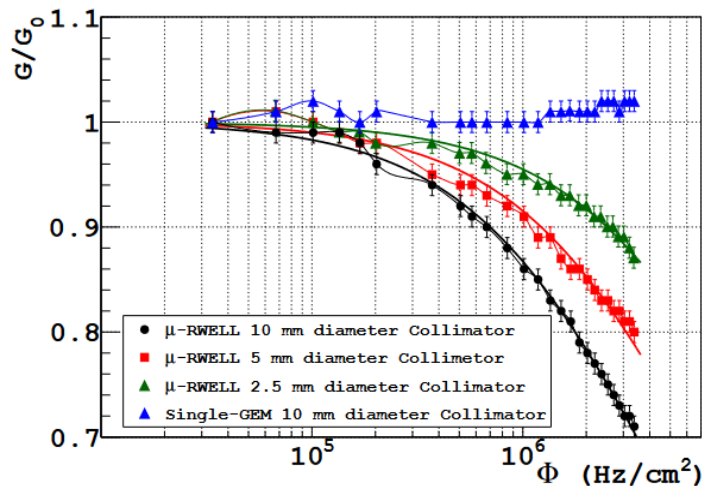
R&D History – Validation with GE1/1

GE1/1-X-S-KOREA

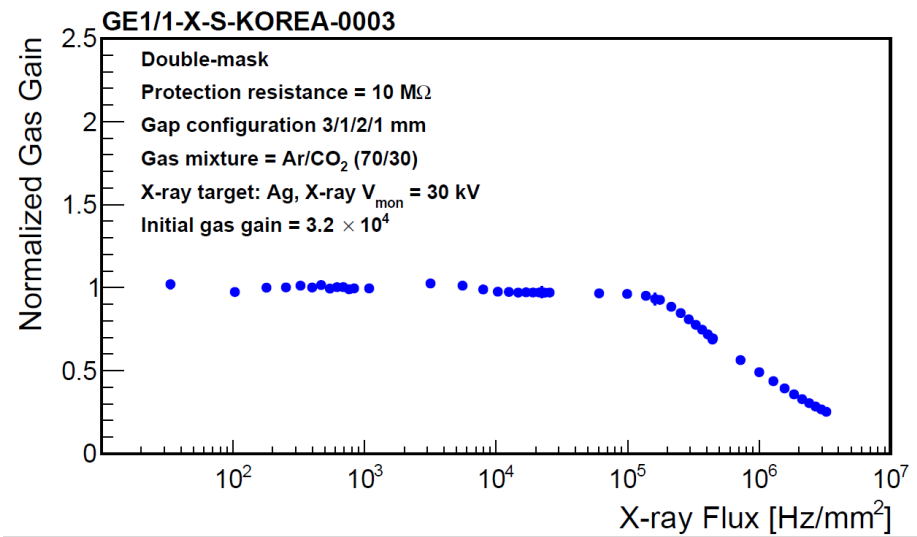


μ RWELL

- μ RWELL is an attractive detector
 - Good position ($\sim 70\text{--}80\ \mu\text{m}$) & time resolution ($\sim 6\ \text{ns}$)
 - Further research is needed on the aging effect, but it is at least more robust than MWPC
 - Mass production friendly, and cheap
 - Easy handling (rigid) and assembly without foil stretch
- Low rate capability compared to GEM
 - \Rightarrow For experiments with low occupancy, μ RWELL will be used widely (my guess)
 - \Rightarrow If low material budget is needed, MWPC

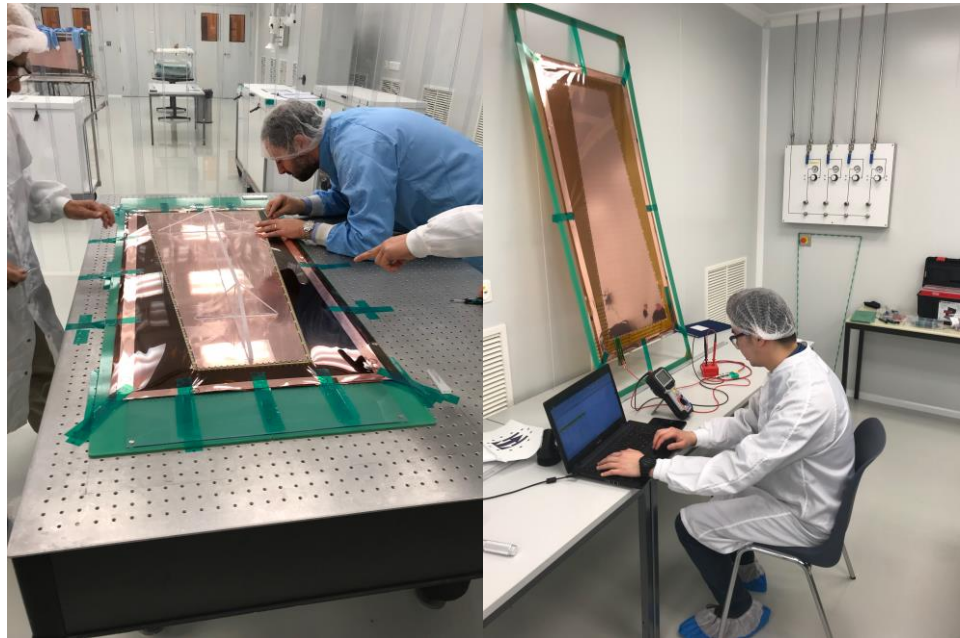


2015 JINST 10 P02008



10 Micro Pattern Gaseous Detectors

- $\mu RWELL$ is an attractive detector
 - Easy handling (rigid) and assembly without foil stretch
- GEM and $\mu RWELL$ share very similar production processes



2019 JINST 14 P05014

